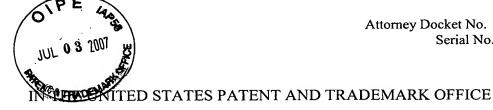
Attorney Docket No. 740756-2671 Serial No.: 10/721,251



In re Patent Application of

Shinji MAEKAWA et al.

Application No. 10/721,251

Filed: November 26, 2003

For: MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE

)

) Group Art Unit 1722

) Confirmation No. 6128

) Examiner: Robert M. KUNEMUND

) Date July 3, 2007

INFORMATION DISCLOSURE STATEMENT

MAIL STOP RCE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98.

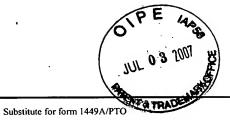
It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initial a copy of this form be returned to the undersigned.

The Commissioner is hereby authorized to charge any fees connected with this filing which may be required now, or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,

Registration No. 50,219

NIXON PEABODY LLP 401 9th Street, N.W. Suite 900 Washington, D.C. 20004-2128 (202) 585-8000



INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

of

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Sheet

Complete if Known			
Application Number	10/721,251		
Filing Date	November 26, 2003		
First Named Inventor	Shinji MAEKAWA		
Art Unit	1722		
Examiner Name	Robert M. KUNEMUND		
Attorney Docket Number	740756-2671		

			U.S. PATENT DOCUME	ENTS	
Examiner Initials	Cite No.1	U.S. Patent Document Number - Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	1	US 6,713,323 B2	03/30/2004	Yamazaki et al.	
	1	US 7,141,822 B2	11/28/2006	Nakamura et al.	, , , , , , , , , , , , , , , , , , ,
		US 6,803,296 B2	10/12/2004	Miyairi	
		US 2006/0292761 A1	12/28/2006	Yamazaki	
		US 2007/0020826 A1	01/25/2007	Yamazaki	
		US 2007/0037309 A1	02/15/2007	Nakamura et al.	
	1				

		FO	REIGN PATENT D	OCUMENTS		
Examiner Initials	Cite No. ¹	Foreign Patent Document Kind Code ⁵ Country Code ³ Number ⁴ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Application of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Τ⁴
		OTHER PRIOR A	RT – NON PATENT L	ITERATURE DOCUMENTS		
Examiner Initials	Cite No. ¹	te Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the				T ²

Examiner	Date	1
Signature	Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

¹ Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.